

1410 NORTH HILTON, BOISE, ID 83706 • (208) 373-0502

C. L. "BUTCH" OTTER, GOVERNOR TONI HARDESTY, DIRECTOR

September 12, 2008

VIA EMAIL

Mr. Jim Robbins
Environmental Specialist
Chevron Pipe Line Company/Northwest Terminalling Company
2875 South Decker Lake Drive
Salt Lake City, UT 84119

RE: Facility ID No. 001-00026, Chevron Pipe Line Company/ Northwest Terminalling

Company, Boise

Draft Tier I Operating Permit for Public Comment

Dear Mr. Robbins:

The Department of Environmental Quality (DEQ) has prepared a draft Tier I operating permit for Chevron Pipe Line Company/Northwest Terminalling Company located in Boise, Idaho in accordance with IDAPA 58.01.01.300 through 386, Rules for the Control of Air Pollution in Idaho. The permit application, the draft permit, and the statement of basis prepared by DEQ will be made available for public review and comment in accordance with IDAPA 58.01.01.364. DEQ will schedule a 30-day public comment period during which you, in addition to any concerned individual or party, may submit written comments or request a public hearing on the permit. To find the exact dates and all other information concerning this public comment period please go to our website:

http://www.deq.idaho.gov/Applications/NewsApp/checkCommentCache.cfm

Enclosed is draft Tier I operating permit No. T1-050032 for your review. You may submit comments during the public comment period if you so choose through DEQ's website at http://www.deq.idaho.gov or directly to me at the email address below.

At the end of the public comment period, DEQ will prepare a written response to the public comments and incorporate changes in the permit as appropriate. A proposed permit will then be submitted to the U.S. Environmental Protection Agency for its review as required by IDAPA 58.01.01.366.

If you have any questions regarding the draft permit or the public comment process, please contact me at (208) 373-0502 or harbi.elshafei@deq.idaho.gov.

Sincerely,

Harbí Elshafeí

Harbi Elshafei Permit Writer Air Quality Division Permit No. T1-050032

Enclosure